L Number	Hits	Search Text	DB	Time stamp
1	2155	(438/624,633,692).CCLS.	USPAT	2002/10/18 13:52
2	1295	(257/635,637-644,760).CCLS.	USPAT	2002/10/18 13:53
3	798	(((438/624,633,692).CCLS.) ((257/635,637-644,760).CCLS.)) and (dielectric adj constant low$1k)	USPAT	2002/10/18 13:55
4	605	((((438/624,633,692).CCLS.) ((257/635,637-644,760).CCLS.)) and (dielectric adj constant low$1k)) and ((stack$3 layer$3 combination combin$3) near4 (stopper$1 resist$3 prevent$3 protect$3 barrier$1))	USPAT	2002/10/18 14:16
5	20	(((((438/624,633,692).CCLS.) ((257/635,637-644,760).CCLS.)) and (dielectric adj constant low$1k)) and ((stack$3 layer$3 combination combin$3) near4 (stopper$1 resist$3 prevent$3 protect$3 barrier$1))) and ((nitrogen n2 n?sub.2 nh3 ammonia nh?sub.3) near15 (stopper$1 resist$3 prevent$3 protect$3 barrier$1) same diffus$3)	USPAT	2002/10/18 14:03
6	585	(((((438/624,633,692).CCLS.) ((257/635,637-644,760).CCLS.)) and (dielectric adj constant low$1k)) and ((stack$3 layer$3 combination combin$3) near4 (stopper$1 resist$3 prevent$3 protect$3 barrier$1))) not ((((((438/624,633,692).CCLS.) ((257/635,637-644,760).CCLS.)) and (dielectric adj constant low$1k)) and ((stack$3 layer$3 combination combin$3) near4 (stopper$1 resist$3 prevent$3 protect$3 barrier$1))) and ((nitrogen n2 n?sub.2 nh3 ammonia nh?sub.3) near15 (stopper$1 resist$3 prevent$3 protect$3 barrier$1) same diffus$3))	USPAT	2002/10/18 14:17
-	20510	(((etch$3 polish$3) adj (stop$4 resist$3 retard$5 prevent$3)) cap$1 capping mask$1 barrier) near3 (layers layered stack$3)	USPAT	2002/10/18 11:58
-	735	((((etch$3 polish$3) adj (stop$4 resist$3 retard$5 prevent$3)) cap$1 capping mask$1 barrier) near3 (layers layered stack$3)) and (((etch$3 polish$3) adj (stop$4 resist$3 retard$5 prevent$3)) cap$1 capping mask$1 barrier) near15 (nitrogen "N-H" nh3 nh?sub.3 nSub.s n2)	USPAT	2002/10/18 12:04
-	96	(((((etch$3 polish$3) adj (stop$4 resist$3 retard$5 prevent$3)) cap$1 capping mask$1 barrier) near3 (layers layered stack$3)) and (((etch$3 polish$3) adj (stop$4 resist$3 retard$5 prevent$3)) cap$1 capping mask$1 barrier) near15 (nitrogen "N-H" nh3 nh?sub.3 nSub.s n2)) and ((((etch$3 polish$3) adj (stop$4 resist$3 retard$5 prevent$3)) cap$1 capping mask$1 barrier) near2 (layered stack$3))	USPAT	2002/10/18 12:22
-	4	(low near2 dielectric adj (constant k)) same ((((etch$3 polish$3) adj (stop$4 resist$3 retard$5 prevent$3)) cap$1 capping mask$1 barrier) near2 (layered stack$3))	USPAT	2002/10/18 13:44